

<b>Notice of References Cited</b>	Application/Control No. 10/043,027		Applicant(s)/Patent Under Reexamination CHUNG ET AL.	
	Examiner William C. Vesperman		Art Unit 2813	Page 1 of 1

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*	C	US-6,218,260	04-2001	Lee et al.	438/398
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